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JUN 1 8 2004 JUN 1 8 2004 JUN 2 PRADENTS Docket No.:

ocket No.: 50090-332

**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Hisaya MORI, et al. : Confirmation Number: 4507

Serial No.: 09/927,368 : Group Art Unit: 2829

Filed: August 13, 2001 : Examiner: J. M. Hollington

For: APPARATUS AND METHOD FOR TESTING SEMICONDUCTOR INTEGRATED

**CIRCUIT** 

## **INFORMATION DISCLOSURE STATEMENT**

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In a ccordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

## **CERTIFICATION PARAGRAPH**

09/927,368

The undersigned certifies that each item of information contained in this Information

Disclosure Statement was first cited in a communication from a foreign patent office in a

counterpart foreign application not more than three months prior to the filing of this Information

Disclosure Statement as described in 37 CFR 1.97(e)(1).

Each non-English language reference was cited in a corresponding German office action

and its relevance discussed therein. A copy of the German office action, together with an

English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including

extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit

account.

Respectfully submitted,

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Date: June 18, 2004

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(PTO-1449)					FILING DATE August 13, 2001		GROUP <b>2829</b>				
				U.S. PATEN	NT DOCUMENTS						
EXAMINER'S INITIALS	CITE NO.	Num	Document Number ber-Kind Code2 (# known)	Publication Dat MM-DD-YYYY		Name of Patentee or Applicant of Cited Document			Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
		US 5,646,521		7/8/1997	Rosenthal et a	Rosenthal et al.		Correspondence to DE 196 31 005 A1			
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			DE 101 45 152 A1	6/6/2002	MITSUBISHI DENKI K.K.				X		
	·	DE 196 31 005 A1		2/6/1997	SCHLUMBERGER TECHNOLOGIES INC.			Correspondence to U.S. 5,646,521			
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EXAMINER						DATE CONSIDERED					

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.